PATENT COOPERATION TREATY

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INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

(Chapter II of the Patent Cooperation Treaty)

(PCT Article 36 and Rule 70)

Applicantle or agentle file reference				
Applicant's or agent's file reference S6070 JV/PL	FOR FURTHER	ACTION	See Form PCT/IPEA/416	
International application No. PCT/IB2004/001346	International filing date 08.04.2004	e (day/month/year)	Priority date (day/month/year) 17.04.2003	
International Patent Classification (IPC) or C23C16/34, C23C16/448	national classification and	IIPC		
Applicant L'AIR LIQUIDE, SOCIETE ANONY	ME A DIRECTOIRE	ET		
right in a	mamilied to the applica	ant according to Article	this International Preliminary Examining	
2. This REPORT consists of a total of 5 sheets, including this cover sheet.				
3. This report is also accompanied by ANNEXES, comprising:				
a. sent to the applicant and to the International Bureau) a total of sheets, as follows:				
sheets of the description, claims and/or drawings which have been amended and are the basis of this report and/or sheets containing rectifications authorized by this Authority (see Rule 70.16 and Section 607 of the Administrative Instructions).				
sheets which supersede earlier sheets, but which this Authority considers contain an amendment that goes beyond the disclosure in the international application as filed, as indicated in item 4 of Box No. I and the Supplemental Box.				
b. (sent to the International I sequence listing and/or ta Box Relating to Sequence	vies relateu mereio in	COMPUTER RESEARCH to	nber of electronic carrier(s)) , containing a rm only, as indicated in the Supplemental ve Instructions).	
4. This report contains indications re	elating to the following	items:		
☑ Box No. I Basis of the op	inion			
☐ Box No. II Priority				
☐ Box No. III Non-establishm	nent of opinion with rea	ard to novelty inventi	ve step and industrial applicability	
☐ Box No. IV Lack of unity of	invention	and to novery, inventi-	ve step and industrial applicability	
⊠ Box No. V Reasoned state applicability; cit	ement under Article 35 ations and explanation	(2) with regard to nove as supporting such stat	elty, inventive step or industrial tement	
Box No. VI Certain docume		•		
Box No. VII Certain defects in the international appl				
☐ Box No. VIII Certain observa	ations on the internatio	nal application		
Date of submission of the demand		Date of completion of	this report	
14.10.2004		02.09.2005	•	
Name and mailing address of the international		Authorized Officer		
preliminary examining authority: European Patent Office - P.B NL-2280 HV Rijswijk - Pays E Tel. +31 70 340 - 2040 Tx; 31	las	Lavéant, P	Julius Palanage, eagle to de la company de l	
Fax: +31 70 340 - 3016		Telephone No. +31 70	0 340-	

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

International application No. PCT/IB2004/001346

_	Box No. I Basis of the repo	ort		
1.	. With regard to the language , this report is based on the international application in the language in which it was filed, unless otherwise indicated under this item.			
	☐ international search (u	nslations from the original language into the following language, translation furnished for the purposes of: nder Rules 12.3 and 23.1(b)) national application (under Rule 12.4) y examination (under Rules 55.2 and/or 55.3)		
2.		of the international application, this report is based on (replacement sheets which reiving Office in response to an invitation under Article 14 are referred to in this are not annexed to this report):		
	Description, Pages			
	1-13	as originally filed		
	Claims, Numbers			
	1-17 .	as originally filed		
	Drawings, Sheets			
	1/5-5/5	as originally filed		
	☐ a sequence listing and/or a	ny related table(s) - see Supplemental Box Relating to Sequence Listing		
3.	The amendments have resulted in the cancellation of: ☐ the description, pages ☐ the claims, Nos. ☐ the drawings, sheets/figs ☐ the sequence listing (specify): ☐ any table(s) related to sequence listing (specify):			
4.	 ☐ This report has been established as if (some of) the amendments annexed to this report and listed below had not been made, since they have been considered to go beyond the disclosure as filed, as indicated in the Supplemental Box (Rule 70.2(c)). ☐ the description, pages ☐ the claims, Nos. ☐ the drawings, sheets/figs ☐ the sequence listing (specify): ☐ any table(s) related to sequence listing (specify): 			
	* If item 4 applies, s	ome or all of these sheets may be marked "superseded."		



International application No. PCT/IB2004/001346

Box No. V Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement

1. Statement

Novelty (N)

Yes: Claims

9

No: Claims

1-8,10-17

Inventive step (IS)

Yes: Claims

No: Claims

1-17

Industrial applicability (IA)

Yes: Claims

1-17

No: Claims

2. Citations and explanations (Rule 70.7):

see separate sheet

Box No. VI Certain documents cited

 Certain published documents (Rule 70.10) and / or

2. Non-written disclosures (Rule 70.9)

see separate sheet

Re Item V.

Reasoned statement with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement

- 1 The following documents are referred to in this communication:
 - D1: US 2001/048973 A1
 - D2: SMIRNOVA T P ET AL: "SiCN alloys obtained by remote plasma chemical vapour deposition from novel precursors" PREPARATION AND CHARACTERIZATION, ELSEVIER SEQUOIA, NL, vol. 429, no. 1-2,(2003-04-01), pages 144-151
 - D3: VORONKOV M G ET AL: "Silyl derivatives of asymmetric dimethylhydrazine as a regents for synthesis of composite layers in silicon-structures" IZVESTIYA VYSSHIKH UCHEBNYKH ZAVEDENII, MATERIALY ELEKTRONNOI TEKNIKI, vol. 4, 2002, pages 57-60

2 INDEPENDENT CLAIMS

Lack of novelty

The present application does not meet the criteria of Article 33(1) PCT, because the subject-matter of claims 1 and 10 is not new in the sense of Article 33(2) PCT.

- 2.1a Document D1 discloses a method for producing Si₃N₄ by vapor-phase growth, said method being characterized by I) feeding a hydrazine gas and at least 1 precursor gas selected from the group consisting of trisilylamine gas and a silylhydrazine gas into a reaction chamber that holds at least 1 substrate and ii) forming a Si₃N₄ film on said 1 substrate by the reaction of the 2 gases (D1: Claims 1-4, 7-10, figures 1, 6-9, compound 9 and example 1)(Claim 1).
- 2.1b Besides, document D1 discloses a method for producing Si₃N₄ by vapor-phase growth, said method being characterized by I) feeding a silylhydrazine gas into a reaction chamber that holds at least 1 substrate and ii) forming a Si₃N₄ film on said 1 substrate by the decomposition of said silylhydrazine gas (D1: Claims 1-4, 7-10, figures 1, 6-9, compound 9 and example 1)(Claim 10).
- 2.2 In addition, document D2 discloses a method for producing Si₃N₄ by vapor-phase

PCT/IB2004/001346

growth, said method being characterized by I) feeding a silylhydrazine gas into a reaction chamber that holds at least 1 substrate and ii) forming a $\rm Si_3N_4$ film on said 1 substrate by the decomposition of said silylhydrazine gas (D2: pages 144-145)(Claim 10).

2.3 In addition, document D3 discloses a method for producing Si₃N₄ by vapor-phase growth, said method being characterized by I) feeding a silylhydrazine gas into a reaction chamber that holds at least 1 substrate and ii) forming a Si₃N₄ film on said 1 substrate by the decomposition of said silylhydrazine gas (D3: abstract) (**Claim** 10).

3 DEPENDENT CLAIMS 2-9, 11-17

Dependent claims 2-8, 11-17 do not contain any features which, in combination with the features of any claim to which they refer, meet the requirements of the PCT in respect of novelty and/or inventive step (Article 33(2) and (3) PCT).

Re Item VI Certain documents cited

Certain published documents

Application No Patent No Publication date (day/month/year)

Filing date (day/month/year)

Priority date (valid claim) (day/month/year)

EP 144 1042 A

28.07.2004

16.01.2004

23.01.2003